## DEPARTMENT OF \_\_METALLURGICAL AND MATERIALS ENGINNERING\_\_

# NATIONAL INSTITUTE OF TECHNOLOGY, TIRUCHIRAPPALLI

	COURSE PLA	N – PART I			
Name of the programme and specialization	M Tech. (Materials Science and Engineering)				
Course Title	Electrical, Magnetic and Optical Materials				
Course Code	MT 651	No. of Credits 3			
Course Code of Pre- requisite subject(s)	Nil				
Session	July 2023	Section (if, applicable)	NA		
Name of Faculty	Dr. N. Ramesh Babu	Department	MME		
Email	rameshrohith@gmail. com nrb@nitt.edu	Telephone No.	2503464 99444932221		
Name of Course Coordinator(s) (if, applicable)	NA				
E-mail	NA	Telephone No.	NA		
Course Type	Core Course				

#### Syllabus (approved in BoS)

Electrical and Dielectric Materials: Review of electrical conduction - resistivity and dielectric phenomena - concept of polarization - effects of composition, frequency and temperature on these properties - discussion on specific materials used as conductors (OFHC Copper, Al alloys, Fe-Si alloys, amorphous metals) - discussion on specific materials used as dielectrics (ceramics and polymers) - dielectric loss, dielectric breakdown - ferro electricitypiezo and pyro electricity.

Magnetic Materials: Introduction to dia, para, ferri and ferro magnetism - hard and soft magnetic materials - iron- silicon alloys – iron, nickel alloys - ferrites and garnets - (Ag - Mn - Al) alloys - (Cu - Ni-Co) alloy - fine particle magnets - applications of hard and soft magnetic materials - Giant magneto resistance- Nanomaterials.

Semiconducting and Superconducting Materials: Review of semiconducting materials - concept of doping - simple and compound semiconductors - amorphous silicon, oxide semiconductors; amorphous semiconductors - FER, MOSFET and CMOS - Concept of super condcutivity

Production of Electronic Materials: Review of electronic materials - methods of crystal growth for bulk single crystals - zone melting-refining, leveling - synthesis of epitaxial films by VPE, PVD, MBE and MOCVD techniques - lithography; production of silicon - starting applications.

Optical Properties of Materials: Introduction to electromagnetic radiation, atomic and electronic interactions with electromagnetic radiation, optical properties of metals, optical properties of

nonmetals, opacity and translucency in insulators, color of materials, applications of optical phenomena-luminescence, photoconductivity, lasers, optical fibers in communications

### COURSE OBJECTIVES

The objective of this course is to provide students a fundamental understanding of electrical, magnetic and optical properties of materials and to apply those fundamentals for selecting and developing materials for different engineering applications.

COURSE OUTCOMES (CO)	
Course Outcomes	Programme Outcomes (PO)
Course Outcomes	(Enter Numbers only)
After the completion of this course, the student will	
be able to:	
1.Understand the conducting, semiconducting,	(1,2,3)
superconducting, dielectric, ferro-eleletric and	(1,2,3)
piezoelectric behavior of materials	
0. Differentiete ketue en die meenetie	(1,2,3,4,5)
2. Differentiate between diamagnetic, paramagnetic, ferromagnetic, and	
anti-ferromagnetic behavior of materials	
3. Synthesis and processing of semi-conducting	(1,4,6)
materials for engineering applications	
	(1,6,7)
4. Study the effect of composition, structure and	(,,,,,,)
temperature on the properties of the materials.	
5. Describe the interactions of light with materials	(1,2,3)
and its effects at the interface	
6. Understand the working principles of solid state	(1,5,7)
devices, etc.	
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COURSE PLAN – PART II
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COURSE TEACHING AND LEADNING ACTIVITIES

COURSE TEACHING AND LEARNING ACTIVITIES					
S.No.	Week/Contact Hours	Торіс	Mode of Delivery		
1.	1-111	Electrical and Dielectric Materials			
2.	IV-VI	Semiconducting Materials and Superconducting Materials	PPT, Black board		
3.	VII-IX	Magentic Materials			
4.	X-XII	Production and processing of electronic Materials			
5.	XIII-XIV	Optical Properties of Materials			

COURSE ASSESSMENT METHODS (shall range from 4 to 6)				
S.No.	Mode of Assessment	Week/Date	Duration	% Weightage
1	Assignment	3-10-23 to 6-10-23	1 h	15
2	Mid Test	6-11-23 to 10-11-23	1 h	20
3	Quiz	20-11-23 to 24-11-23	1h	20
-	Compensation Test	4-12-23 to 8-12-23	1 h	20
4	Semester exam	18-12-23 to 22-12-23	3 h	45

Attendance mandatory; refer to guidelines on page 5

COURSE EXIT SURVEY (mention the ways in which the feedback about the course shall be assessed)

The feedback from students will be assessed based on the questionnaire prepared by the

institute and expected minimum attainment to be 75%.

COURSE POLICY (preferred mode of correspondence with students, compensation assessment policy to be specified)

The students are expected to attend all the classes except for medical reasons. Minimum attendance of 75% is required for writing the semester examination.

Apart from technical content and presentation, plagiarism will be checked for the written assignments

### MODE OF CORRESPONDENCE (email/ phone etc)

The Course Coordinator is available for consultation at any time.

The phone number and email id will be given to the students at the beginning of the course

### COMPENSATION ASSESSMENT POLICY

Retest will be conducted for the portion of the course completed.

**ATTENDANCE POLICY** (A uniform attendance policy as specified below shall be followed)

- > At least 75% attendance in each course is mandatory.
- > A maximum of 10% shall be allowed under On Duty (OD) category.
- Students with less than 65% of attendance shall be prevented from writing the final assessment and shall be awarded 'V' grade.

#### ACADEMIC DISHONESTY & PLAGIARISM

- Possessing a mobile phone, carrying bits of paper, talking to other students, copying from others during an assessment will be treated as punishable dishonesty.
- Zero mark to be awarded for the offenders. For copying from another student, both students get the same penalty of zero mark.
- The departmental disciplinary committee including the course faculty member, PAC chairperson and the HoD, as members shall verify the facts of the malpractice and award the punishment if the student is found guilty. The report shall be submitted to the Academic office.

The above policy against academic dishonesty shall be applicable for all the programmes.

### ADDITIONAL INFORMATION

The Course Coordinator is available for consultation at any time.

Students can also contact me at any time through phone or by e-mail. Relative grading as per the Institute Policy

### FOR APPROVAL

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Course Faculty

CC-Chairperson

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HOD

### **Guidelines:**

- a) The number of assessments for a course shall range from 4 to 6.
- b) Every course shall have a final assessment on the entire syllabus with at least 30% weightage.
- c) One compensation assessment for absentees in assessments (other than final assessment) is mandatory. Only genuine cases of absence shall be considered.
- d) The passing minimum shall be as per the regulations.

B.Tech. Admitted in				P.G.		
2018	2017	2016 2015				
35% or class average/2 whichever is greater.		Peak/3 whichev			average/2	40%

- e) Attendance policy and the policy on academic dishonesty & plagiarism by students are uniform for all the courses.
- f) Absolute grading policy shall be incorporated if the number of students per course is less than 10.
- g) Necessary care shall be taken to ensure that the course plan is reasonable and is objective.